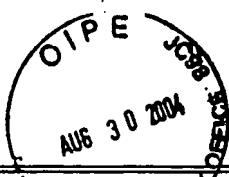


FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary) August 30, 2004			ATTY DOCKET NO. 03500.017976		APPLICATION NO. 10/806,157		
			APPLICANT Tetsuro NAKAMURA et al.				
			FILING DATE March 23, 2004		GROUP 1753		
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*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
/TT/		US-6,465,727 B2	10/15/2002	Maruyama et al.	136	256	
		US-6,660,931 B2	12/09/2003	Toyama et al.	136	256	
		US-5,804,466	09/08/1998	Arao et al.	438	95	
		US-6,613,603 B1	09/02/2003	Sano	438	72	
		US-6,488,995 B1	12/03/2002	Nishimoto et al.	427	574	
		US-6,399,873 B1	06/04/2002	Sano et al.	136	249	
		US-6,303,945 B1	10/16/2001	Saito et al.	257	64	
		US-6,635,899 B2	10/21/2003	Saito et al.	257	64	
		US-6,344,608 B2	02/05/2002	Kariya et al.	136	257	
		US-6,653,165 B2	11/25/2003	Kondo et al.	438	73	
		US-6,706,336 B2	03/16/2004	Kondo et al.	427	588	
		US-6,172,296 B1	01/09/2001	Iwasaki et al.	136	256	
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/TT/		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
		4-119843	04/21/1992	Japan			Abstract
		3273294	02/01/2002	Japan			Abstract
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/TT/		Sannomiya, H., et al., "a-SiC/a-Si/a-SiGe MULTI-BANDGAP STACKED SOLAR CELLS WITH BANDGAP PROFILING," Technical Digest of the International PVSEC-5, Kyoto, Japan, 1990. Energy Conversion Laboratories, SHARP Corp. Pp. 387-390.					
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/Thanh Truc Trinh/			(07/12/2007)				

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



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/TT/		US-6,123,824	09/26/2000	Sano et al.	205	124	
		US-6,472,248 B2	10/29/2002	Shiozaki et al.	438	97	
		2003/0075717 A1	04/24/2003	Kondo et al.	257	64	
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		2003/0028486 A1	02/06/2003	Nakamura	705	50	
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/TT/		2001-339079	12/07/2001	Japan			Abstract
		2001-152930	06/05/2001	Japan			Abstract
		10-140373	05/26/1998	Japan			Abstract
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/TT/		Inoue, Y., et al. "Optical confinement effect in a-SiGe solar cells on stainless steel substrates," 29p-MF-2, 51st Academic Lecture by the Applied Physics Society of Japan, Fall 1990. P. 747.					
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